



IFC

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1792

Application No.: 10/827,426

Examiner: W. FLETCHER

Filed: April 20, 2004

Docket No.: 119295

For: CLEANING METHOD, STORAGE METHOD, PATTERN FORMATION METHOD,  
DEVICE MANUFACTURING METHOD, ELECTRO-OPTICAL DEVICE, AND  
ELECTRONIC APPARATUS

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the April 9, 2008 Restriction Requirement, Applicant provisionally elects Group I, claims 1-5, with traverse.

It is respectfully submitted that the subject matter of all claims 1-14 is sufficiently related that a thorough search for the subject matter of any one Group of claims would encompass a search for the subject matter of the remaining claims. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it is stated that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions" (emphasis added). It is respectfully submitted that this policy should apply in the present application in order to avoid unnecessary delay and expense to Applicant and duplicative examination by the Patent Office.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,



James A. Oliff  
Registration No. 27,075

Srikant Viswanadham  
Registration No. 60,111

JAO:SQV/jcp

Date: May 6, 2008

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 320850**  
**Alexandria, Virginia 22320-4850**  
**Telephone: (703) 836-6400**

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